

VIA eFILE

Form PTO-1449

Applicant: Henryk Struszczyk

Serial No.: 10/501,202

Filing Date: July 9, 2004

For: METHODS OF PRODUCING MODIFIED MICROCRYSTALLINE
CHITOSAN AND USES THEREFOR

Sheet 1 of 4

Confirmation No.: 3240

Att'y Docket No.: 16497.115

Art Unit: 1651

SUPPLEMENTAL INFORMATION DISCLOSURE CITATIONS MADE BY APPLICANT

U.S. Patents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Date</u>	<u>Name</u>
BAW 1	4,970,150	11/13/1990	Yaku, et al.
2	5,554,445	09/10/1996	Struszczyk, et al.
3	5,720,793	02/24/1998	Kato, et al.
4	2007/0087415	11/27/2006	Struszczyk, et al.
5	2007/0129326	11/27/2006	Struszczyk, et al.
6	2007/0087997	11/27/2006	Struszczyk, et al.

Foreign Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Publication Date</u>	<u>Country or Patent Office</u>
BAW 7	JP 63182304	07/27/1988	Japan
8	JP 64018530	01/23/1989	Japan
9	JP 01185301	07/24/1989	Japan
10	JP 02006950	01/11/1990	Japan
11	JP 02069502	03/08/1990	Japan

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Examiner <u>Initial*</u>	Document <u>Number</u>	<u>Publication Date</u>	<u>Country or Patent Office</u>
LM 12	JP 06293801	10/21/1994	Japan
13	JP 9031104	02/04/1997	Japan
14	JP 02969431	11/02/1999	Japan
15	PL 160897	04/30/1993	Poland
16	WO 03/057736	07/17/2003	PCT

Other Documents

(including author, title, pertinent pages, etc.)

Examiner

Initial*

LM 17	DATABASE CHEMABS 'Online! Chemical Abstracts Service, Columbus, Ohio, US; retrieved from STN Database accession no. 123:172489 XP002236421 abstract & PL 160 897 A (INSTYTUT WLOKIEN CHEMICZNYCH) 30 April 1993 (1993-04-30)
18	DATABASE CHEMABS 'Online! Chemical Abstracts Service, Columbus, Ohio, US; retrieved from STN Database accession no. 128:296087 XP002236422 abstract & LIU YANRU ET AL.: FUJIAN SHIFAN DAXUE XUEBAO, vol. 13, no. 3, 1997, pages 67-70
19	DATABASE WPI Section Ch, Week 199951 Derwent Publications Ltd., London, GB; Class All, AN 1997-161509 XP002236424 & JP 02 969431 B (KITOSAN SHOKUHHIN KOGYO KK), 2 November 1999 (1999-11-02) abstract

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Issue Notifications, Notices of Allowance, and Office Actions

Examiner
Initial*

Patent or Serial
Number

Document

Mail Date

RA20

2007/0087997

Office Action

07/02/2007

Examiner:



Date Considered:

1/25/2008

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References Cited by Applicants

While the filing of Information Disclosure Statements is voluntary, the procedure is governed by the guidelines of Section 609 of the Manual of Patent Examining Procedure and 37 C.F.R. §§ 1.97 and 1.98. To be considered a proper Information Disclosure Statement, Form PTO-1449 shall be accompanied by a copy of each listed patent or publication or other item of information and a translation of the pertinent portions of foreign documents (if an existing translation is readily available to the applicant), an explanation of relevance of each reference not in the English language, and should be submitted in a timely manner as set out in MPEP Sec. 609.

Examiners will consider all citations submitted in conformance with 37 C.F.R. § 1.98 and MPEP Sec. 609 and place their initials adjacent the citations in the spaces provided on this form. Examiners will also initial citations not in conformance with the guidelines which may have been considered. A reference may be considered by the Examiner for any reason whether or not the citation is in full conformance with the guidelines. A line will be drawn through a citation if it is not in conformance with the guidelines AND has not been considered. A copy of the submitted form, as reviewed by the Examiner, will be returned to the applicant with the next communication. The original of the form will be entered into the application file.

Each citation initialed by the Examiner will be printed on the issued patent in the same manner as references cited by the Examiner on Form PTO-892.

The reference designations "A1," "A2," etc. (referring to Applicant's reference 1, Applicant's reference 2, etc.) will be used by the Examiner in the same manner as Examiner's reference designations "A," "B," "C," etc. on Office Action Form PTO-1142.

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